Se	arch	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/074,752	SPITLER ET AL.	
Examiner	Art Unit	
John m. Coonev	1711	

	SEARCHED		
Class	Subclass	Date	Examiner
264	45.1, 241		
521	99, 130		
521	163, 164	1	<b>\</b>
523	218, 219	12/6/2006	JMC
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
Interferen	t SearchSee ce Search tout	12/6/2006	JMC

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
Inventor	12/6/2006	JMC
Appeal Conference /w Michener & Seidleck	12/6/2006	JMC
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